



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 2, 2026

IGI Report Number

LG835604420

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MARQUISE BRILLIANT

Measurements

13.29 X 6.44 X 4.17 MM

GRADING RESULTS

Carat Weight

2.04 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG835604420

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS

60%

15%

44%

64.8%

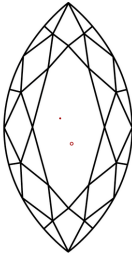
Pointed

Slightly Thick To Thick (Faceted)



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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2.04 CARATS

E

Color Grade

VS 1

Clarity Grade

64.8%

65%

Depth

Slightly Thick To Thick (Faceted)

Table

Pointed

Girdle

EXCELLENT

Culet

EXCELLENT

Polish

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Symmetry

EXCELLENT

Fluorescence

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